

S13 3	0	(impurity near3 content) same ((control adjust) near (power (ion adj beam)))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:36
S13 4	0	(impurity near3 content) same ((control adjust) near (power))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:36
S13 5	0	(impurity near3 control) same (adjust near power)	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:36
S13 6	44	(plasma near display) same ((protecti\$4 adj3 film) near (form\$6 manufactur\$4))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:39
S13 7	3	("5462922" "5496583" "5891531").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/12 14:10
S13 8	1	2000-172476	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:10
S13 9	1	2000-173476	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:10
S14 0	1	2000-173476	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:11
S14 1	2	"2000173476"	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:12
S14 2	125	protection near film near formation	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:15
S14 3	99952	(protection near film near formation) and (plasma near dis)play	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:12
S14 4	3	(protection near film near formation) and (plasma near display)	EPO; JPO; DERWENT	OR	OFF	2005/06/12 14:12
S14 5	41	(film near (silicon Si)) same (power near (adjust\$4 control\$5))	US-PGPUB; USPAT	OR	OFF	2005/06/12 14:16
S14 6	2	(plasma near4 display) same ((protective adj3 film) near4 silicon)	US-PGPUB; USPAT	OR	OFF	2005/08/02 14:40
S14 7	38	(plasma near4 display) and ((protective adj3 film) near4 silicon)	US-PGPUB; USPAT	OR	OFF	2005/08/02 15:23
S14 8	0	(plasma near4 display) and ((protective adj3 film) near4 (magnesium Mg)near3 silicon)	US-PGPUB; USPAT	OR	OFF	2005/08/02 14:41
S14 9	0	(plasma near4 display) and ((protective adj3 film) same ((magnesium Mg) near3 silicon))	US-PGPUB; USPAT	OR	OFF	2005/08/02 14:41
S15 0	1	(plasma near4 display) and ((protective adj3 film) same ((magnesium "MgO") near3 silicon))	US-PGPUB; USPAT	OR	OFF	2005/08/02 14:42

S15 1	1	(plasma near4 display) and ((protective adj3 film) same ((magnesium "MgO") near3 silicon))	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:42
S15 2	4	(plasma near4 display) and ((protective adj3 film) near4 silicon)	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:43
S15 3	2	(plasma near4 display) and (jitter same (protective adj3 film))	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:44
S15 4	5513	(protect\$4 adj3 film) same ((Mg magnesium) or silicon)	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:47
S15 5	83	((protect\$4 adj3 film) same ((Mg magnesium) or silicon)) and (plasma near3 display)	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:51
S15 6	3	((protect\$4 adj3 film) same ((Mg magnesium) and silicon)) and (plasma near3 display)	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:48
S15 7	9	((protect\$4 adj3 film) same (silicon)) and (plasma near3 display)	EPO; JPO; DERWENT	OR	OFF	2005/08/02 14:52
S15 8	118	313/590.ccls.	US-PGPUB; USPAT	OR	OFF	2005/08/02 15:00
S15 9	6	("5693958" "5959403" "5962975" "5980991" "5990617" "6218784").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/02 15:15
S16 0	24	takenouchi-t\$.in.	US-PGPUB; USPAT	OR	OFF	2005/08/02 15:42
S16 1	354	takenouchi-t\$.in.	EPO; JPO; DERWENT	OR	OFF	2005/08/02 15:42
S16 2	18	takenouchi-t\$.in. and MgO	EPO; JPO; DERWENT	OR	OFF	2005/08/03 15:32
S16 3	173	(plasma near4 display) same (discharge near3 gas near3 (xe xenon))	US-PGPUB; USPAT	OR	OFF	2005/08/02 15:57
S16 4	878	(plasma near4 display) same (protect\$5 near3 (film layer))	US-PGPUB; USPAT	OR	OFF	2005/08/02 16:31
S16 5	183	S164 and silicon	US-PGPUB; USPAT	OR	OFF	2005/08/02 15:58
S16 6	12	(plasma near4 display) same (protect\$5 near3 (film layer) near3 (si silicon\$))	US-PGPUB; USPAT	OR	OFF	2005/08/02 16:32
S16 7	2	("5952137" "6525471").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/02 16:41
S16 8	4	("4603082" "5703437" "5705886" "6229582").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/02 16:48

S16 9	968	315/169.4.ccls.	US-PGPUB; USPAT	OR	OFF	2005/08/03 09:43
S17 0	0	315/169.4.ccls. and (jitter same (plasma near4 display))	US-PGPUB; USPAT	OR	OFF	2005/08/03 09:44
S17 1	82	315/169.4.ccls. and ((protect\$4 near3 (film layer)) same (plasma near4 display))	US-PGPUB; USPAT	OR	OFF	2005/08/03 11:06
S17 2	1	("6650063").URPN.	USPAT	OR	OFF	2005/08/03 09:58
S17 3	6	("5703437" "5938494" "6149967" "6245394" "6329751" "6650063").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/03 10:08
S17 4	20	315/169.4.ccls. and ((protect\$4 near3 (film layer)) same (plasma near4 display) same (xe xenon))	US-PGPUB; USPAT	OR	OFF	2005/08/03 11:13
S17 5	2	"2001135238"	EPO; JPO; DERWENT	OR	OFF	2005/08/03 11:17
S17 6	2	"08236028"	EPO; JPO; DERWENT	OR	OFF	2005/08/03 11:20
S17 7	2	"2000173476"	EPO; JPO; DERWENT	OR	OFF	2005/08/03 11:30
S17 8	2150	protect\$3 near3 layer near3 (si silicon)	EPO; JPO; DERWENT	OR	OFF	2005/08/03 11:31
S17 9	17	(protect\$3 near3 layer near3 (si silicon)) and ((plasma near3 display) (gas adj3 discharge))	EPO; JPO; DERWENT	OR	OFF	2005/08/03 11:32
S18 0	0	takenouchi-t\$.in. and MgO	US-PGPUB; USPAT; IBM_TDB	OR	OFF	2005/08/03 13:51
S18 1	6	takenouchi.in. and MgO	US-PGPUB; USPAT; IBM_TDB	OR	OFF	2005/08/03 13:51
S18 2	0	takeyoshi-t\$.in. and MgO	EPO; JPO; DERWENT	OR	OFF	2005/08/03 15:11
S18 3	6	"6242864"	US-PGPUB; USPAT	OR	OFF	2005/08/03 15:33
S18 4	11	("3716742" "4116792" "4258080" "4794308" "5811923" "5993543" "6013309" "6242864" "6255780" "6344080" "6379783").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/03 15:38
S18 5	12	("3811062" "5852347" "5900694" "6043605" "6097149" "6211614" "6242864" "6252353" "6266033" "6281628" "6329751" "6411033").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/03 15:43

S86	28	hideo.in. and (surface adj discharge)	US-PGPUB; USPAT	OR	OFF	2002/01/22 09:56
S87	46	(plasma adj display adj panel) and (apparatus near (making or manufacturing))	USPAT	OR	OFF	2004/02/05 17:13
S88	8	("5717291" "5747939" "6008582" "6034475" "6051928" "6149482" "6184621" "6450850").PN.	USPAT	OR	OFF	2004/02/05 17:36
S89	153	roy-sikha.xa.	US-PGPUB; USPAT	OR	OFF	2005/06/08 17:37
S90	240	(plasma near display) same (protect\$5 near film)	US-PGPUB; USPAT	OR	OFF	2005/06/08 17:40
S91	3	(plasma near display) same (protect\$5 near film near (silicon magnesium calcium iron))	US-PGPUB; USPAT	OR	OFF	2005/06/08 17:40
S92	2	("5952137" "6525471").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/08 17:43
S93	390	park.in. and (plasma near display)	US-PGPUB; USPAT	OR	OFF	2005/06/08 17:43
S94	0	(plasma near3 display) same (protect\$4 near film near silicon)	US-PGPUB; USPAT	OR	OFF	2005/06/09 16:31
S95	142	(plasma near3 display) and ((protect\$4 near film) same silicon)	US-PGPUB; USPAT	OR	OFF	2005/06/09 16:34
S96	13	(plasma near3 display) same ((protect\$4 near film) same silicon)	US-PGPUB; USPAT	OR	OFF	2005/06/09 16:41
S97	746	(plasma near display) same (protect\$4 adj (film layer))	US-PGPUB; USPAT	OR	OFF	2005/06/09 16:42
S98	130	(plasma near display) same (protect\$4 adj (film layer)) same ("Mg\$" magnesium)	US-PGPUB; USPAT	OR	OFF	2005/06/09 16:42
S99	2	("5952137" "6525471").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/09 16:59
S100	19	("20010015628" "20020047578" "20020130823" "20020135546" "20020167466" "20020180669" "20030011540" "20030090441" "20030122494" "20030184533" "20040090395" "20040104869" "20040150354" "6317105" "6344715" "6486611" "6657397" "6707436" "6756950").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/09 17:01

S10 1	3	("3983445" "5701056" "5818168").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/09 17:14
S10 2	10	("1955211" "3364057" "3508869" "3847583" "3850683" "5003221" "5510141").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/09 17:45
S10 3	2	"10291854"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/06/09 17:59
S10 4	2755	takenouchi.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/06/09 18:00
S10 5	75841	"takenouchi.in.and" "MgO"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/06/09 18:00
S10 6	28	takenouchi.in. and MgO	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/06/09 18:11
S10 7	22	(plasma near display) same ((formation forming manufactur\$3) near (protect\$4 adj film))	US-PGPUB; USPAT	OR	OFF	2005/06/09 18:38
S10 8	0	(plasma near display) same (discharge adj gas) same ("5%" near e)	US-PGPUB; USPAT	OR	OFF	2005/06/09 18:38
S10 9	5	(plasma near display) same (discharge adj gas) same ("5%" near xe)	US-PGPUB; USPAT	OR	OFF	2005/06/09 18:43
S11 0	103	(plasma near display) same (discharge adj gas) same (xe)	US-PGPUB; USPAT	OR	OFF	2005/06/09 18:43
S11 1	6	(plasma near display) same (method near (forming near (protect\$4 adj film)))	EPO; JPO; DERWENT	OR	OFF	2005/06/12 12:00
S11 2	3	(plasma near display) same (method near (forming near (protect\$4 adj film)))	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/12 12:00
S11 3	9	(plasma near display) and (method near (forming near (protect\$4 adj film)))	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/12 12:03
S11 4	5672	(protective adj3 film) same silicon	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:05
S11 5	86	S114 and (plasma near display)	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:04

S11 6	1	((protective adj3 film) near ("MgO" (magnesium adj oxide))) same silicon	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:06
S11 7	62	((film) near ("MgO" (magnesium adj oxide))) same silicon	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:06
S11 8	5	("6242864").URPN.	USPAT	OR	OFF	2005/06/12 12:10
S11 9	2	("3863089" "5454861").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/06/12 12:51
S12 0	8	(film near formation) same source same (power near adjust\$4)	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:58
S12 1	0	(film near formation) same (source adj3 material) same (power near adjust\$4)	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:57
S12 2	0	(film near formation) same (content near (source adj3 material) near (power near adjust\$4))	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:58
S12 3	0	(film near formation) and (content near (source adj3 material) near (power near adjust\$4))	US-PGPUB; USPAT	OR	OFF	2005/06/12 12:58
S12 4	0	(film near formation) same (source adj material) same (power near adjust\$4)	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:00
S12 5	0	(film adj3 (forming formation)) same (impurity near control) same power	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:13
S12 6	36	(film adj3 (forming formation)) same (impurity near control)	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:19
S12 7	4	(film adj3 (forming formation)) same (content near control) same (power electric\$5)	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:21
S12 8	454	(film adj3 (forming formation)) same (content) same (power electric\$5)	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:22
S12 9	17	(film adj3 (forming formation)) and ((content near control) same (power electric\$5))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:26
S13 0	3	(film adj3 (forming formation)) and ((content) same (power near (control adjust)))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:34
S13 1	83	438/3.ccls. and (control same (power))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:33
S13 2	2	(silicon near3 content) same ((control adjust) near (power (ion adj beam)))	US-PGPUB; USPAT	OR	OFF	2005/06/12 13:35